



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Makoto NAKADATE

Group Art Unit: UNKNOWN

Application No.: 10/782,947

Filed: February 23, 2004

Docket No.: 118824

For: MASK, MANUFACTURING METHOD FOR MASK, MANUFACTURING APPARATUS
FOR MASK, METHOD FOR MAKING FILM OF LIGHT-EMITTING MATERIAL,
ELECTROOPTICAL APPARATUS AND ELECTRONIC APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. An English language Abstract of one or more non-English language reference is attached. See References 1 & 2.
- ☒ 3. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 1 & 2.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Kirk D. Berkhimer
Registration No. 59,874

JAO:KDB/pdw
Date: January 2, 2008

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--